

Celadon Tungsten Carbide Cleaning Substrate

Tungsten Carbide: 6", 8" wafers and custom made shapes

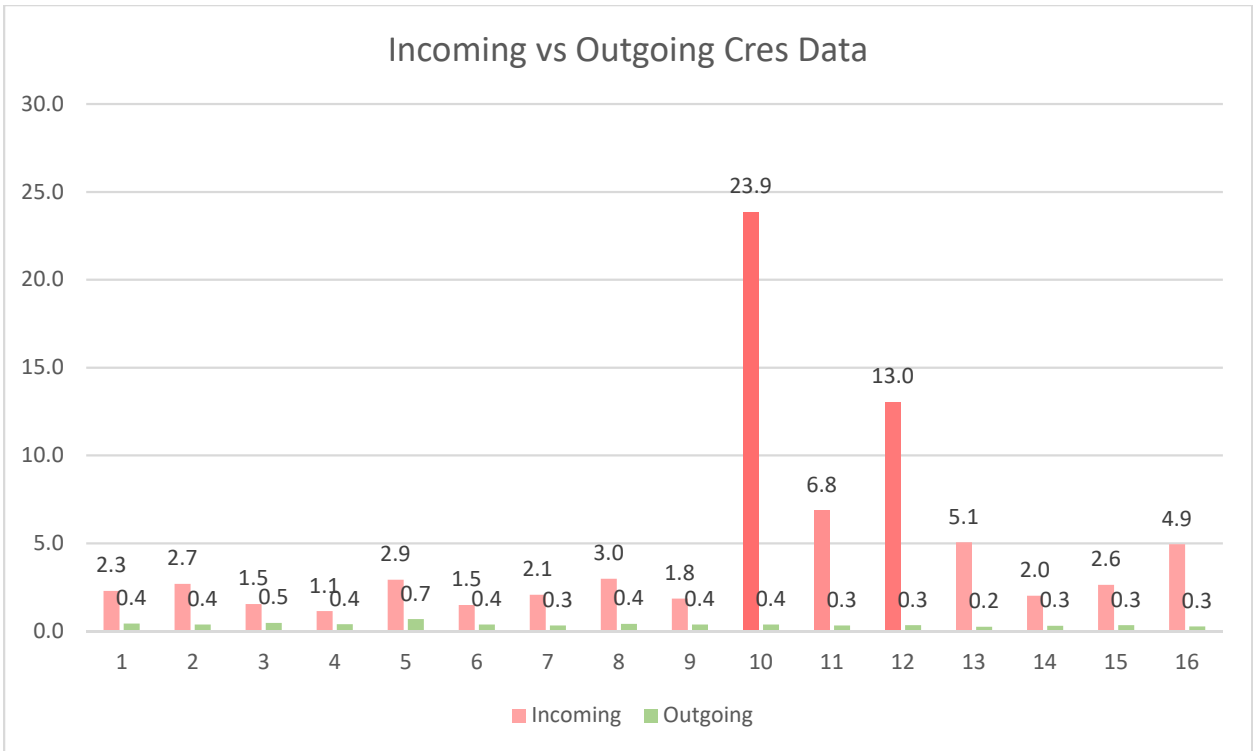
■ Features

- Celadon Tungsten Carbide [WC] is custom pressed and lapped to achieve our optimal roughness specification
- Celadon WC is compatible with all Celadon product lines
- Used for Cres management in Fabs, often in tandem with in situ ITS Probe Polish
- In High Power / High Current applications, Celadon WC is used to keep probe tips clean so higher resistance doesn't cause melted probes.
- Manage Cres with just 2 – 3 touchdowns
- **Use Celadon Tungsten Carbide at the **SAME** overdrive as your standard test overdrive.



■ Standard Sizes [Custom Sizes Also Available]

Part Number	Description
27023	6" Tungsten Carbide [WC] wafer with notch w/ Protective Case Ø150.06mm x 750µm thick Wafer weight : 0.4534 lbs [7.25 oz]
27024	8" Tungsten Carbide [WC] wafer with notch w/ Protective Case Ø200.00mm x 750µm thick Wafer weight : 0.8155 lbs [13.05 oz]
26376	Tungsten Carbide Cleaning Substrate 14.5mm x 16.0mm x 0.750mm For Cascade S300
27829	Tungsten Carbide Cleaning Substrate 50mm x 50mm x 0.750mm
26833	WC Cleaning Pad 19.0mm x 19mm.0 x 0.75mm For Summit 12k Auxiliary Cleaning Chuck



This is actual incoming vs outgoing data after being treated with Tungsten Carbide 4 times.

Example Auxiliary Chuck:

